



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ammar Derraa

Serial No.: 10/654,226

Filed: September 2, 2003

For: METHOD OF FABRICATING FIELD
EMISSION ARRAYS EMPLOYING A
HARD MASK TO DEFINE COLUMN
LINES AND ANOTHER MASK TO
DEFINE EMITTER TIPS AND RESISTORS

Confirmation No.: 4741

Examiner: M. Santiago

Group Art Unit: 2879

Attorney Docket No.: 2269-3882.8US
(99-0017.08/US)

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May 4, 2005

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AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

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Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Examiner:

Please amend the above-referenced application as follows:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks begin on page 9 of this paper.